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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#9 7/24/02

| | | |
|---|---|---|
| In re Application of: | ) | |
| | : | Examiner: H. Nguyen |
| YOSHINORI OHSAKI | ) | |
| | : | Group Art Unit: 2851 |
| Application No.: 09/577,978 | ) | |
| | : | |
| Filed: May 25, 2000 | ) | |
| | : | |
| For: PROJECTION EXPOSURE APPARATUS, AND DEVICE MANUFACTURING METHOD USING THE SAME | ) | |
| | : | July 3, 2002 |

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Commissioner for Patents
Washington, D.C. 20231

PETITION UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated January 3, 2002 for three months from April 3, 2002 to July 3, 2002.

Submitted herewith is a check for $920.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account 06-1205. A duplicate copy of this petition is enclosed.

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on July 3, 2002 (Date of Deposit)

Michael K. O'Neill
Name of Attorney for Applicant

Signature

July 3, 2002
Date of Signature

Applicant's undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

Attorney for Applicant

Registration No. 32,622

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